Sheet 1 of 2 APPLICATION NO. Form PTO-1449 ATTY DOCKET NO. US Dept. of Commerce PATENT & TRADEMARK OFFICE D/A3207IQ 10/772, 693 INFORMATION DISCLOSURE STATEMENT Jun Ma et al. **APPLICANT** (Use several sheets if necessary) **GROUP ART UNIT** FILING DATE 2/5/04 2883 U.S. PATENT DOCUMENTS SUB **EXAMINER PUBLICATION** NAME OF PATENTEE CLASS CLASS DOCUMENT NUMBER DATE INITIAL 01/06/1998 Joel A. Kubby 347 65 5,706,041 216 27 5,851,412 12/22/1998 Joel A. Kubby 257 415 Joel A. Kubby et al. 03/26/2002 6,362,512 B1 438 52 04/30/2002 Joel A. Kubby et al. 6,379,989 B1 359 201 6,002,507 12/14/1999 Philip D. Floyd et al. 359 201 Philip D. Floyd et al. 01/11/2000 6,014,240 Robert L. Wood et al. 310 307 06/01/1999 5,909,078 310 307 Vijayakumar R. Dhuler et al. 5,994,816 11/30/1999 310 307 Vijayakumar R. Dhuler et al. 02/08/2000 6,023,121 310 307 09/05/2000 Vijayakumar R. Dhuler et al. 6,114,794 FOREIGN PATENT DOCUMENTS **TRANSLATION PUBLICATION** DATE NAME OF PATENTEE OR APPLICANT COUNTRY DOCUMENT NUMBER Y/N OTHER DOCUMENTS (Including Author (in CAPS), Title, Publication Date, Pages, etc.) Yogesh B. Gianchandani and Khalil Najafi, "Bent-Beam Strain Sensors," Journal of Microelectromechanical Systems, Vol. 5, No.1, March 1996, pages 52-58

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